		Application	Application 10/633,833		OFGS File No. P/2291-110			
APPLI	CANT'S ART CITATION E several spects if necessary)	Applicant	Applicant Etsuro ENDO					
,	3 0 2006	Filing Date	Filing Date August 4, 2003		Group Art Unit			
		ATENT D	OCUMENTS (copies not s	submitted)	)			
Examined Initial	RADEM	Date MM-YYYY		Class	Sub- class	Filing l	Date priate	
AR		01-2003	Name Zhou, et. al.	Class		Пирро	priace	
	US-	71-2003	Zilou, et. ai.	ļ		<del></del>		
	US-	<del></del>						
	US-						· · · · · · · · · · · · · · · · · · ·	
	US-							
	US-				!			
	US-							
	US-							
		FOREIG	N PATENT DOCUMENT	rs				
	Document Number	Date MM-YYYY	Country	Class	Sub- class	Translation Yes No		
AR	WO 02/35736 A1	05-2002	PCT			Abstract		
				<del> </del>				
					_			
	<u></u>				<u> </u>			
	T		(Including Author, Title, Date,			<u></u>		
AR	Examination Report issued by English Patent Office in connection with corresponding							
V	Great Britain app	plication no	o. GB0318338.1 on Februa	ary 27, 20	06	···········		
			<del></del>					
Examiner	./Alejandro Rivero/	Date Co	onsidered 07/18/2006					
FXAMINE	R: Initial if citation considered, wheth	er or not citation	n is in conformance with MPEP § 609:	Draw line thro	ugh citation if	not in conform	ance and	

Application 10/633,833 OFGS File No. P/2291-110 T'S ART CITATION Applicant Etsuro ENDO se several sheets if necessary) Filing Date August 4, 2003 Group Art Unit \_\_ U.S. PATENT DOCUMENTS (copies not submitted) Filing Date
If Appropriate Sub-Date MM-YYYY Class class Document Number Name US-US-US-US-US-US-US-US-FOREIGN PATENT DOCUMENTS Translation Date MM-YYYY Sub-Class **Document Number** Country class Yes AR 08-2000 X 2000-228647 Japan AR CN 1294334 A 05-2001 China OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) AR Office Action issued by Chinese Patent Office in connection with corresponding Chinese application no. 200410080454.0 on December 30, 2005 English translation of Office Action issued by Chinese Patent Office on December 30, 2005 in connection with corresponding Chinese application no. 200410080454.0 Examiner /Alejandro Rivero/ Date Considered 07/18/2006 EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.